

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: O'DONNELL

Application No.: 09/472,757

Filed: December 27, 1999

Title: INSITU POST ETCH PROCESS TO REMOVE REMAINING PHOTORESIST AND

RESIDUAL SIDEWALL PASSIVATION

Attorney Docket No.:

LAM1P133/P0582

Examiner: Umez Eronini, L.

Group: 1765

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Box Non-Fee Amendment, Commissioner for Patents, Washington, D.C. 20231 on

November 27, 2001.

Signed:

Sue Funchess

## ASSOCIATE POWER OF ATTORNEY

Box Non-Fee Amendment Commissioner for Patents Washington, D.C. 20231 RECEIVED

DEC 3 1 2001

Sir:

TC 1700

The undersigned attorney of record in the subject patent application hereby grants an Associate Power of Attorney to add Jeffrey J. Brooks, Registration No. 35,834 and Michael Brandt, Registration No. 39,119, both of Lam Research Corporation, to prosecute this application and transact all business in the Patent and Trademark Office connected therewith.

Please send all correspondence for this application as follows:

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DATES TO AND TRADEMARK OFFICE

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Respectfully submitted,

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